
Monday, November 30

08:00 Registration

09:00 **N. Barsan**

Welcome and introduction

■ **Advances in technology**

Chair N. Barsan

09:10 **L. Maedler, University of Bremen, Germany**

Route to selectivity: FSP multi-layered MOX films

10:00 **I. Freund, Micronas GmbH, Germany**

CMOS Integration of the suspended gate FET gas sensor

10:50 *Coffee Break*

11:10 **D. Briand, EPFL, Switzerland**

Manufacturing of MOX gas sensors: towards plastic substrates?

11:50 C. Oberhuettinger and G. Mueller, EADS, Germany

Simultaneous measurement of resistive and surface ionization gas response on tin oxide surfaces

12:10 N. Blair et al, Alphasense Ltd, UK

Ultra low-power micro-hotplate smart gas-sensor (ULoGS) employing tungsten oxide

12:30 Z. Öztürk et al, Gebze Institute of Technology, Turkey

Metal oxide nanowires and nanotubes for resistive gas detection

12:50 *Lunch*

13:40 M. Andersson and A. Lloyd Spetz, Linköping University, Sweden

The use of Metal Oxides in Field Effect High Temperature Gas Sensors

14:00 T. Pisarkiewicz et al, AGH University of Science and Technology, Poland

Gas measurement microsystem in LTCC technology

14:20 T. Doll et al., Johannes-Gutenberg-University Mainz, Germany

External electric field influence on the adsorption-desorption processes of gases in semiconductors



■ **Novel materials**

Chair K. Shimanoe

14:40 **Jong-Heun Lee, Korea University, Korea**

Gas Sensors using Hierarchical and Hollow Oxide Nanostructures

15:30 Coffee Break

16:00 **K. Shimanoe, Kyushu University, Japan**

Material design based on wet process for highly sensitive semiconductor gas sensors

16:50 M.N. Rumyantseva et al, Moscow State University, Russia

Sensor properties of hybrid SnO₂-polysilazane materials

17:10 A. Haensch et al., University of Tuebingen, Germany

Rare earth oxycarbonates based CO₂ chemoresistive sensors

17:30 R. Pearce et al, Linköping University, Sweden

Effect of water vapour on ZnO and Ga doped ZnO nanoparticle sensor gas response

17:50 S. Pokhrel et al, University of Bremen, Germany

Ultra fine nano single crystals of WO₃ for gas sensing applications

18:10 S. Mathur et al, University of Cologne, Germany

Individual metal oxide nanowires in chemical sensing: Challenges and prospects

19:30 Dinner



Tuesday, December 1

■ New application fields

Chair U. Weimar

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- 09:00 **N. Ishibashi and K. Kaneyasu, Figaro Engineering, Japan**
Development and application of semiconductor gas sensor using MEMS technology
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- 09:50 **Hyung-Gi Byun, Kangwon National University, Korea**
Intelligent sensor system for non-invasive health care monitoring
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- 10:40 *Coffee Break*
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- 11:00 **H. Ulmer, AppliedSensor, Germany**
New applications and development trends for micro-machined MOS gas sensors
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- 11:50 **O. Kiesewetter, UST Umweltsensortechnik GmbH, Germany**
Highly dynamic identification of various gases at trace levels with the UST Triplesensor®
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- 12:40 *Lunch*
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- 13:40 **A. Bos, C-it BV, The Netherlands**
Mass-employable, MO-based electronic noses and device-independent calibration models
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- 14:00 **A. Valleron et al, Ecole Nationale Supérieure des Mines, France**
Exhaust gas sensor based on tin dioxide for automotive application
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- 14:20 **A. Ponzoni et al, Brescia University**
Conductometric gas-sensors based on metal-oxide nanowires for chemical warfare agents detection
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- 14:40 **Closing address**
N. Barsan, K. Shimano, U. Weimar
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